

INFORMATION DISCLOSURE STATEMENT TRANSMITTAL To Commissioner For Patents Enclosed herewith is a Form PTO-1449, any required copies of documents listed thereon, and any concise explanation of their relevance is indicated below per 37 CFR 1.97.	Application Number	
	Filing Date	
	First Named Inventor	JACQUEMIN, JEAN-PHILIPPE
	Group Art Unit	
	Examiner Name	
	Atty. Docket Number	FR02 0118 US

U.S. PATENT DOCUMENTS					
Examiner Initials*	Cite No. ¹	Document Number No.-Kind Code ² (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns Lines, Where Relevant Passages or Relevant Figures Appear
	1	US- 3 605 486	09/20/1971	N. C. ADERHOLM ET AL	
	2	US- 5 438 402	08/01/1995	GUPTA VIJAY	
	3	US- 4 972 720	11/27/1990	WU WEN-LI	
	4	US- 5 838 446	11/17/1998	METH JEFFREY S. ET AL.	
		US-			
		US-			

FOREIGN PATENT DOCUMENTS						
Examiner Initials*	Cite No. ¹	Document Number (ctry ³ -no.-kind ² , if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of cited document	Pages, Columns Lines, Where Relevant Passages or Relevant Figures Appear	T ⁶
	1	FR 2 681 427	03/19/1993	BAUDINAUD VINCENT		

NON-PATENT LITERATURE DOCUMENTS			
Examiner Initials*	Cite No. ¹	Include name of the author (in capital letters), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ⁶
	1	A. W. STEPHENS AND J. L. VOSSEN: "ABSTRACT: MEASUREMENT OF INTERFACIAL BOND STRENGTH BY LASER SPALLATION"; JOURNAL OF VACUUM SCIENCE AND TECHNOLOGY; Vol. 13, no. 1; February 1976; pages 38-29	
	2	J. H. JEONG ET AL: "INTRINSIC STRESS IN CHEMICAL VAPOUR DEPOSITED DIAMOND FILMS: AN ANALYTICAL . . . ; JOURNAL OF APPLIED PHYSICS 90(3); Pages 1227-1236; Aug. 1, 2001.	
	3	MICHEL GODIN ET AL. : "QUANTITATIVE SURFACE STRESS MANagements USING A MICROcantilever"; APPLIED PHYSICS LETTERS 79(4); Pages 551-553; July 23 rd , 2001	
	4	R.H. DAUSKARDT ET AL: "ADHESION AND DEBONDING OF MULTI-LAYER THIN FILM STRUCTURES"; ENGINEERING FRACTURE MECHANICS 61(1998); Pages 141-162.	
	5	GURAY TAS ET AL: "ELECTRON DIFFUSION IN METALS STUDIED BY PICOSECOND ULTRASONICS "; PHYSICAL REVIEW; Pages 15 046 – 15 054; Vol. 49 (21); June 1 st , 1994.	

Examiner Signature	/David Rogers/	Date Considered	03/16/2010
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* EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹ Unique citation designation number. ² See attached Kinds of U.S. Patent Documents. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. ⁶ Applicant is to place a check mark here if English language Translation is attached.

ALL REFERENCES CONSIDERED EXCEPT WHERE LINED THROUGH. //DaR//